PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
YOUNG HWAN KIM	11/02/2012
YONG TAE KIM	11/02/2012
JINN IL CHOI	11/02/2012

RECEIVING PARTY DATA

Name:	KOREA INSTITUTE OF SCIENCE AND TECHNOLOGY	
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State/Country:	KOREA, REPUBLIC OF	
Postal Code:	136-791	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	13672943

CORRESPONDENCE DATA

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NAME OF SUBMITTER: Loren K. Thompson

Total Attachments: 2

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PATENT

REEL: 029270 FRAME: 0815

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UNITED STATES OF AMERICA ASSIGNMENT

In consideration of the payment of ASSIGNEE to ASSIGNOR of the sum of One Dollar (\$1.00), the receipt of which is hereby acknowledged, and for other good and valuable consideration,

ASSIGNOR:

Young Hwan KIM

#1011-612, Jugong Apt., 666, Sanggye-dong, Nowon-gu, Seoul, 139-200, Republic of Korea

Yong Tae KIM

#105-1502, Bundang Doosan Weve Apt., 192, Geumgok-dong, Bundang-gu, Seongnam-si, Gyeonggi-do, 463-850, Republic of Korea

Jinn Il CHOI

#28-910, Miseong Apt., Apgujeong-dong, Gangnam-gu, Seoul, 135-785, Republic of Korea

hereby sells, assigns and transfers to

ASSIGNEE:

KOREA INSTITUTE OF SCIENCE AND TECHNOLOGY

39-1, Hawolgok-dong, Seongbuk-gu, Seoul, 136-791, Republic of Korea

and the successors, assigns and legal representatives of the ASSIGNEE the entire right, title and interest for the United States and its territorial possessions in and to, any and all improvements which are disclosed in the Application entitled

TITLE OF INVENTION:

METHOD OF MANUFACTURING PRAM USING LASER INTERFERENCE LITHOGRAPHY

and which is found in (37 CFR 3.21)

(a) Not yet filed U.S. patent application executed on even date herewith

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	(b)	(b) Not yet filed U.S. patent application executed on(insert date of execution of Declaration)			
	\boxtimes	To comply with 37 CFR 3.21 for rec	cordal of this assignment, I, an ASSIGNOR and request my attorney to insert below the		
		U.S. patent or provisional patent appli	cation No.		
	(d)	International application Nofiled on			
and, in an continuat examinat	ion,	division, renewal, or substitute thereo	id invention by the above application or any f, and as to letters patent any reissue or re-		
A been or w	SSIC	SNOR hereby covenants that no assign e made or entered into which would co	nment, sale, agreement or encumbrance has nflict with this assignment and sale.		
promptly and legal same in a deliver to	with equany is AS to ap	all pertinent facts and documents relativalents as may be known and accessinterference, litigation or proceeding residence or its legal representatives apply for, obtain, maintain, issue and enfit and said equivalents thereof which maintain.	SNEE will, upon its request, be provided ting to said invention and said Letters Patent ble to ASSIGNOR and will testify as to the clated thereto and will promptly execute and any and all papers, instruments or affidavits force said application, said invention and said ay be necessary or desirable to carry out the		
11	N W	TNESS WHEREOF, we have set our l	nand and seal		
	Note: The date of signing must be the same as the date of execution of the application if item (a) was checked above.				
	/ o	2/20/2 ate	Young Hwan KIM		
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